

U.S.S.N. 10/050,322

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Tsai et al.

Group Art Unit: 1756

Serial No.: 10/050,322

Examiner: N. M. Barreca

Filed: 01/15/2002

In Response to Office Action

Dated: 04/13/2005

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For: A BI-LAYER PHOTORESIST DRY DEVELOPMENT AND REACTIVE
ION ETCH METHOD

Attorney Docket No.: 67,200-613

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION

I hereby certified that this correspondence is (1) ☐ being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Commissioner for Patents, P O Box 1450, Alexandria, VA 22313-1450 on October __, 2005; or (2) ☒ being facsimile transmitted to the United States Patent and Trademark Office at facsimile number (571)-273-1379 on October 28, 2005.

Randy W. Tung
Printed Name

Signature

10/28/05
Date

Please forward all correspondence to
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STATEMENT OF COMMON OWNERSHIP PURSUANT TO 35 USC 103(c)

Applicants' attorney of record state that Tsai et al. (6,787,455) and Applicants' instant application were, at the time the invention was made, owned by Taiwan Semiconductor Manufacturing Company. Therefore, Examiners use of Tsai et al. as a reference in a 103(a) rejection appears to be improper under 35 USC §103(C).

Respectfully submitted,

TUNG & ASSOCIATES, PLL

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08-02-'05 10:36 FROM-TUNG & ASSOCIATES

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T-413 P02/14 U-662

U.S.S.N. 10/050,322

Second SUPPLEMENTAL AMENDMENT

Assistant Commissioner
for Patents
P.O. Box 1450
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 07/07/2005 please
allow entry of the following amendments to place the Application
in better form for Appeal.

OK
to
enter
now

11/26/04